



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Application of :  
Toshio KODAMA et al. :  
Appln. No. 10/525,311 : Art Unit - 2881  
Filed: April 18, 2005 : Examiner - Kiet Tuan Nguyen  
For: ION BEAM DEVICE AND ION :  
BEAM PROCESSING METHOD : Docket No. S005-5460 (PCT)

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MS Amendment  
COMMISSIONER FOR PATENTS  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE**

S I R:

In response to the Office Action mailed October 5,  
2006, applicants amend their application as follows:

**ADDITIONAL FEE:**

No additional fee is believed required in connection  
with this response. However, should it be determined that a  
fee is due, authorization is hereby given to charge any such  
fee to our Deposit Account No. 01-0268.